



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 09/754,926  
Filing Date ..... January 4, 2001  
Inventor ..... Kie Y. Ahn  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Kielin, Erik J.  
Attorney's Docket No. .... MI22-1533  
Title: Methods of Forming Assemblies Comprising Silicon-Doped Aluminum Oxide

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References –See Attached Form PTO-1449

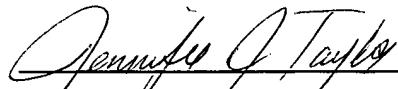
The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: June 25, 2004

By:

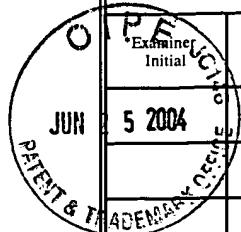


Jennifer J. Taylor, Ph.D.

Reg. No. 48,711

LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Kie Y. Ahn et al.FILING DATE  
January 4, 2001GROUP  
2813

## U.S. PATENT DOCUMENTS



*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
5 2004	AA	6,344,403 B1	02-2002	Madhukar et al.			
	AB	6,438,030 B1	08-2002	Hu et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		
	AS		
	AT		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.